

PATENT

Attorney Docket No. MTI-31532

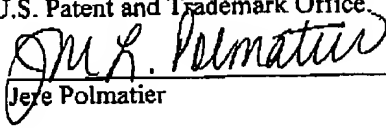
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Weimer, Ronald A.  
Serial No.: 09/941,827  
Filing Date: August 29, 2001  
For: Method of Improved High K Dielectric-Polysilicon Interface for CMOS Devices  
Examiner: PHAM, Thanhha S.  
Group Art Unit: 2813  
Confirmation No.: 7551

**CERTIFICATION OF SUBMISSION**

I hereby certify that, on the date shown below, this correspondence is being transmitted via facsimile no. 571-273-1696 addressed to Examiner PHAM at the U.S. Patent and Trademark Office.

Date: July 19, 2006

  
Jere Polmatier

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE**

Sir:

This response replies to Examiner Pham's telephone call of July 18, 2006. Applicant has accepted the Examiner's proposed amendments and hereby requests consideration of the pending claims in the above-identified patent application based on the remarks herein.

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks** begin on page 32 of this paper.